RIALTO, the laser ion source at ALTO: Production of Ag and Ga beams

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Outline

- ❀ Laser resonance ionization.
- ❀ Old layout of RIALTO and its needs.
- ℜ RIALTO upgraded system.
- ℜ Ag and Ga production
- ℜ Summary and outlook

Laser resonance ionization



RIALTO (old layout)



RIALTO current layout



Stabilization system





2.0

2.0 2.5

Time (hours)

2.5

6

2.00

Ga ionization



Ga production

69Ge 39.05 h ε = 100.00%	70Ge STABLE 20.57%	71Ge 11.43 d ε = 100.00%	72Ge STABLE 27.45%
68Ga 67.71 min ε = 100.00%	69Ga STABLE 60.108%	70Ga 21.14 min β ⁻ = 99.59% ε = 0.41%	71Ga STABLE 39.892%
67Zn STABLE 4.04%	68Zn STABLE 18.45%	69Zn 56.4 min β ⁻ = 100.00%	70Zn ≥ 2.3E+17 y 0.61% 2β [−]





Laser ON-OFF effect. Gamma-ray spectrum recorded with HPGe detectors at the COeCO station for ⁸⁰Ga with surface ionization ion source (purple) and with the laser ionization (pink). Factor 8 enhancement with lasers.

Ag ionization



Silver production



without laser

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Summary and outlook

We produced Ag and Ga beams
using our upgraded laser ion source.

- ℜ Radioactive silver production.
- ℜ New Nd:YAG with UV output.
- ❀ Sb scheme development.